



Attorney Docket: 071469-0307699
Client Reference: ES-040

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 4102

YUE

Application No.: 10/812,355

Group Art Unit: 1765

Filed: March 30, 2004

Examiner: Chen, Kin Chan

Title: METHOD AND SYSTEM FOR ADJUSTING A CHEMICAL OXIDE REMOVAL
PROCESS USING PARTIAL PRESSURE

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated January 12, 2006, the period for reply being extended to May 12, 2006 by the Petition for One-Month Extension of Time filed herewith, please amend the above-identified application as follows:

05/12/2006 SZEWDIE1 00000053 033975 10012355
01 FC:1251 120.00 DA